

IN THE CLAIMS:

Claims 1-5, 11-17, 20, 21, 24 and 27 were previously withdrawn. Claims 6, 8-10, 18, 19, 22, 23, 25 and 26 have been amended herein. All of the pending claims 1 through 27 are presented below. This listing of claims will replace all prior versions and listings in the application. Please enter these claims as amended.

Listing of Claims:

1. (Withdrawn) A 64M semiconductor memory device comprising:
a semiconductor die encapsulated in a package, the package having an encapsulating body and electrically conductive interconnect pins extending outwardly from the body;
a total of from 64,000,000 to 68,000,000 functional and operably addressable memory cells arranged in multiple memory arrays formed on the die the individual functional and operably addressable memory cells occupying area on the die within the memory arrays, the occupied area of all functional and addressable memory cells on the die having a total combined area which is no greater than 53 mm^2 ; and
peripheral circuitry and pitch circuitry formed on the die relative to the memory arrays; the peripheral circuitry electrically interconnecting with the pins and including operably interconnected control and timing circuitry, address and redundancy circuitry, data and test path circuitry, and voltage supply circuitry which collectively enable full access to all addressable memory cells of the memory arrays.
2. (Withdrawn) The semiconductor memory device of claim 1 wherein the die is fabricated to include a total of four or less composite conductive line layers.
3. (Withdrawn) The semiconductor memory device of claim 1 wherein the peripheral circuitry, the pitch circuitry and the memory arrays have a total combined continuous surface area on the die which is less than or equal to 106 mm^2 .

4. (Withdrawn) The semiconductor memory device of claim 1 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include at least five composite conductive line layers, the occupied area of all functional and operable memory cells on the die having a total combined area on the die which is no greater than 40 mm^2 .

5. (Withdrawn) The semiconductor memory device of claim 1 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include at least five composite conductive line layers; the peripheral circuitry, the pitch circuitry and the memory arrays having a total combined continuous surface area on the die which is less than or equal to 93 mm^2 .

6. (Currently amended) A semiconductor device including a memory, the semiconductor device comprising:

a semiconductor die encapsulated in a package, the package having an encapsulating body and electrically conductive interconnect pins extending outwardly from the body;

a total of ~~from~~ at least 16,000,000 ~~to 17,000,000~~ functional and operably addressable memory cells arranged in multiple memory arrays formed on the semiconductor die, the ~~individual~~ functional and operably addressable memory cells occupying area on the semiconductor die within the memory arrays, the occupied area of all functional and addressable memory cells on the semiconductor die having a total combined area which is no greater than 14 mm^2 ; and

peripheral circuitry and pitch circuitry formed on the semiconductor die relative to the memory arrays; the peripheral circuitry electrically interconnecting with the interconnect pins and including operably interconnected control and timing circuitry, address and redundancy circuitry, data and test path circuitry, and voltage supply circuitry which collectively enable full access to all addressable memory cells of the memory arrays.

7. (Previously presented) The semiconductor device of claim 6 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include a total of four or less conductive line layers.

8. (Currently amended) The semiconductor device of claim 6 wherein the peripheral circuitry, the pitch circuitry and the memory arrays have a total combined continuous surface area on the semiconductor die which is less than or equal to 35 mm^2 .

9. (Currently amended) The semiconductor device of claim 6 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include at least five conductive line layers, the occupied area of all functional and operable memory cells on the semiconductor die having a total combined area ~~on the die~~ which is no greater than 11 mm^2 .

10. (Currently amended) The semiconductor device of claim 6 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include at least five conductive line layers; the peripheral circuitry, the pitch circuitry and the memory arrays having a total combined continuous surface area on the semiconductor die which is less than or equal to 32 mm^2 .

11. (Withdrawn) A 4M semiconductor memory device comprising:
a semiconductor die encapsulated in a package, the package having an encapsulating body and electrically conductive interconnect pins extending outwardly from the body;
a total of from 4,000,000 to 4,500,000 functional and operably addressable memory cells arranged in multiple memory arrays formed on the die, the individual functional and operably addressable memory cells occupying area on the die within the memory arrays, the occupied area of all functional and addressable memory cells on the die having a total combined area which is no greater than 3.3 mm^2 ; and

peripheral circuitry and pitch circuitry formed on the die relative to the memory arrays; the peripheral circuitry electrically interconnecting with the pins and including operably interconnected control and timing circuitry, address and redundancy circuitry, data and test path circuitry, and voltage supply circuitry which collectively enable full access to all addressable memory cells of the memory arrays.

12. (Withdrawn) The semiconductor memory device of claim 11 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include a total of four or less composite conductive line layers.

13. (Withdrawn) The semiconductor memory device of claim 11 wherein the peripheral circuitry, the pitch circuitry and the memory arrays have a total combined continuous surface area on the die which is less than or equal to 11.0 mm^2 .

14. (Withdrawn) The semiconductor memory device of claim 11 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include at least five composite conductive line layers, the occupied area of all functional and operable memory cells on the die having a total combined area on the die which is no greater than 2.5 mm^2 .

15. (Withdrawn) The semiconductor memory device of claim 11 wherein the peripheral circuitry, the pitch circuitry, and the memory arrays are fabricated to include at least five composite conductive line layers; the peripheral circuitry, the pitch circuitry and the memory arrays having a total combined continuous surface area on the die which is less than or equal to 10.2 mm^2 .

16. (Withdrawn) A 64M semiconductor memory device comprising:
a semiconductor die encapsulated in a package, the package having an encapsulating body and electrically conductive interconnect pins extending outwardly from the body;
a total of from 64,000,000 to 68,000,000 functional and operably addressable memory cells arranged in multiple memory arrays formed on the die, at least one of the memory arrays containing at least 100 square microns of continuous die surface area having at least 128 of the functional and operably addressable memory cells; and
peripheral circuitry and pitch circuitry formed on the die relative to the memory arrays; the peripheral circuitry electrically interconnecting with the pins and including operably interconnected control and timing circuitry, address and redundancy circuitry, data and test path circuitry, and voltage supply circuitry which collectively enable full access to all addressable memory cells of the memory arrays.

17. (Withdrawn) The semiconductor memory device of claim 16 wherein at least one of the memory arrays containing at least 100 square microns of continuous die surface area having at least 170 of the functional and operably addressable memory cells.

18. (Currently amended) A semiconductor device including a memory, the semiconductor device comprising:

a semiconductor die encapsulated in a package, the package having an encapsulating body and electrically conductive interconnect pins extending outwardly from the body;

a total of ~~from~~ at least 16,000,000 to ~~17,000,000~~ functional and operably addressable memory cells arranged in multiple memory arrays formed on the semiconductor die, at least one of the memory arrays containing at least one area of 100 square microns of continuous semiconductor die surface area having at least 128 of the functional and operably addressable memory cells; and

peripheral circuitry and pitch circuitry formed on the semiconductor die relative to the memory arrays;

the peripheral circuitry electrically interconnecting with the interconnect pins and including operably interconnected control and timing circuitry, address and redundancy circuitry, data and test path circuitry, and voltage supply circuitry which collectively enable full access to all addressable memory cells of the memory arrays.

19. (Currently amended) The semiconductor device of claim 18 wherein the at least one of the memory arrays containing at least one area of 100 square microns of continuous semiconductor die surface area has at least 170 of the functional and operably addressable memory cells.

20. (Withdrawn) A 4M semiconductor memory device comprising:
a semiconductor die encapsulated in a package, the package having an encapsulating body and electrically conductive interconnect pins extending outwardly from the body;
a total of from 4,000,000 to 4,500,000 functional and operably addressable memory cells arranged in multiple memory arrays formed on the die, at least one of the memory arrays containing at least 100 square microns of continuous die surface area having at least 128 of the functional and operably addressable memory cells; and
peripheral circuitry and pitch circuitry formed on the die relative to the memory arrays; the peripheral circuitry electrically interconnecting with the pins and including operably interconnected control and timing circuitry, address and redundancy circuitry, data and test path circuitry, and voltage supply circuitry which collectively enable full access to all addressable memory cells of the memory arrays.

21. (Withdrawn) The semiconductor memory device of claim 20 wherein at least one of the memory arrays containing at least 100 square microns of continuous die surface area having at least 170 of the functional and operably addressable memory cells.

22. (Currently amended) A semiconductor device including a memory, the semiconductor device comprising:

a total of no more than 68,000,000 functional and operably addressable memory cells arranged in multiple memory arrays formed on a semiconductor die; and

circuitry formed on the semiconductor die permitting data to be written to and read from one or more of the functional and operably addressable memory cells, at least one of the memory arrays containing at least one area of 100 square microns of continuous semiconductor die surface area having at least 128 of the functional and operably addressable memory cells.

23. (Currently amended) The semiconductor device of claim 22 wherein ~~the~~ a total number of functional and operably addressable memory cells on the semiconductor die is no more than 17,000,000.

24. (Withdrawn) The semiconductor memory device of claim 22 wherein the total number of functional and operably addressable memory cells on the semiconductor die is no more than 4,500,000.

25. (Currently amended) The semiconductor device of claim 22 wherein the at least one of the memory arrays containing at least one area of 100 square microns of continuous semiconductor die surface area has at least 170 of the functional and operably addressable memory cells.

26. (Currently amended) The semiconductor device of claim 22 wherein the at least one of the memory arrays containing at least one area of 100 square microns of continuous semiconductor die surface area has at least 170 of the functional and operably addressable memory cells, and ~~the~~ a total number of functional and operably addressable memory cells on the semiconductor die is no more than 17,000,000.

27. (Withdrawn) The semiconductor memory device of claim 22 wherein at least one of the memory arrays containing at least 100 square microns of continuous die surface area having at least 170 of the functional and operably addressable memory cells, and the total number of functional and operably addressable memory cells on the semiconductor die is no more than 4,500,000.